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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10715628
	Filing Date		2003-11-17
	First Named Inventor	Garo J. Derderian	
	Art Unit	1792	
	Examiner Name	Zervigon, Rudy	
	Attorney Docket Number	MI22-2427	

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	1	4444812		1984-04-24	Gutsche	
	2	4545327		1985-10-08	Campbell et al.	
	3	4592933		1986-06-03	Meyerson et al.	
	4	4724159		1988-02-09	Yamazaki	
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	7	4904621		1990-02-27	Loewenstein et al.	
	8	4910043		1990-03-20	Freeman et al.	

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	9	4949669		1990-08-21	Ishii et al.	
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20	6344151	B1	2002-02-05	Chen et al.	
21	6638880	B2	2003-10-28	Yamamuka et al.	
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	1	HORII, Sadayoshi, et al., "Metalorganic Chemical Vapor Deposition of HfO ₂ Films through the Alternating Supply of Tetrakis(1-methoxy-2-methyl-2-propoxy)-Hafnium and Remote-Plasma Oxygen". Jpn. J. Appl. Phys. Vol. 42 (2003), pp. 5176-5180, Part 1, No. 8, 15 August 2003.	<input type="checkbox"/>
	2	SUNDQVIST, J., et al., "Atomic layer deposition of polycrystalline HfO ₂ films by the HfI ₄ -O ₂ precursor combination". Thin Solid Films. Volume 427, Issues 1-2, 3 March 2003, pp. 147-151.	<input type="checkbox"/>

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